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PATENT
8017-1096

IN THE U.S. PATENT AND TRADEMARK OFFICE

In application of

Yasuaki TSUCHIYA et al.

Conf. 4719

Application No. 10/622,735

Group 1755

Filed July 21, 2003

SLURRY FOR POLISHING COPPER-BASED
METAL

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 1, 2004

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying documents, copies of which are attached to this statement, are made of record on the enclosed Form PTO-1449.

A concise explanation of the relevance of these items is that these references were cited by the Taiwanese Patent Office in an Official Action (U.S. Patent No. 6,171,352 is the U.S. counterpart for Taiwanese Patent 455626). A copy of the Taiwanese Official Action in which they were cited is attached hereto. **An English translation of the Taiwanese Official Action is also attached hereto.**

Respectfully submitted,

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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

* Abstract provided for the Examiner's convenience